



Docket No.: 050063-0064

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Junichi SHIOMI, et al.

**RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE**

Application No.: 10/086,877

Customer No.: 20277

Filed: March 04, 2002

Confirmation No.: 1977

Group Art Unit: 2623

Examiner: Chong R. Kim

Title: DETECTION OF AN END POINT OF POLISHING A SUBSTRATE

AMENDMENT UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated July 26, 2005, please amend the above-identified application as follows:

OK to enter

OK

10/19/05